



IP 1763 A

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

: MAIL STOP: AMENDMENT

Naoaki OGURE et al.

: Confirmation No. 7255

Serial No. 09/866,843

: Docket No. 2001_0686A

Filed May 30, 2001

: Group Art Unit 1763

COATING, MODIFICATION AND
ETCHING OF SUBSTRATE SURFACE
WITH PARTICLE BEAM IRRADIATION
OF THE SAME

: Examiner G.A. GOUDREAU

AMENDMENT

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action mailed April 7, 2004, the time for responding thereto being extended for one month in accordance with a Petition for Extension submitted herewith, please amend the above-identified application as follows: